



10/590067

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:—	SHIMOMURA	Examiner:	Unknown
Serial No.:	10/590067	Group Art Unit:	Unknown
Filed:	21 August 2006	Docket No.:	8279.1153USWO
Title:	POLISHING PAD AND METHOD FOR MANUFACTURE OF SEMICONDUCTOR DEVICE USING THE SAME		

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service, as first class mail, with sufficient postage, in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, Alexandria, VA 22313, on 23 October 2006.

By: 
Name: Ralynn Wilhelm

PRELIMINARY AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In connection with the above-identified application filed herewith, please enter the following preliminary amendment.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 6 of this paper